



*STW*  
PATENT  
8020-1021-1

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of:

Yoshihisa MATSUBARA

Confirmation No. 7618

Serial No. 10/624,596

GROUP 2814

Filed July 23, 2003

Examiner Ginette Peralta

SEMICONDUCTOR DEVICE AND MANUFACTURING  
METHOD OF THE SAME

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

September 17, 2004

Sir:

In response to the Official Action of June 17, 2004,  
please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing  
of claims that begins on page 2 of this paper.

**Remarks** begin on page 4 of this paper.